

09/28/01



JC893 U.S. PTO

PATENT

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Case Docket No.: 2001 P 11914 USDate: September 28, 2001

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09/965093



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ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231
Box PATENT APPLICATION

Sir:

Transmitted herewith for filing is the patent application of:

Inventor(s): Linda Chen and Larry Varnerin

For: DIRECT, NON-DESTRUCTIVE MEASUREMENT OF RECESS DEPTH IN A WAFER

This application includes:

10 pages: specification and claims
2 sheets of drawings, formal/ X Informal
 photographs

Also enclosed is:

 An Assignment of the invention to Assignee(s):
 X Infineon Technologies North America Corp.
 International Business Machines Corporation or ITR, LP; IT AG; UMC, etc.
 A certified copy of application
X Declaration and Power of Attorney
X Information Disclosure Statement pursuant to 37 CFR 1.56
 X Form PTO-1449
 Form PTO-1595
X Post Card

The filing fee has been calculated as shown below:

FOR:	(Col. 1) NO. FILED	(Col. 2) NO. EXTRA RATE	OTHER THAN A SMALL ENTITY FEE
BASIC FEE	XXXXXXXX	XXXXXXXX	XXXXX \$710
TOTAL CLAIMS	<u>10</u> - 20 =	<u>0</u>	X \$18 = \$ <u>0</u>
INDEP CLAIMS	<u>2</u> - 3 =	<u>0</u>	X \$80 = \$ <u>0</u>
* MULTIPLE DEPENDENT CLAIM PRESENTED			+ 270 = \$0
ASSIGNMENT(S)	<u>0</u>		X \$40 = \$0

TOTAL \$710.00

Infineon Technologies North America Corp.
c/o Siemens Corporation
Intellectual Property Department
186 Wood Avenue South
Iselin, NJ 08830
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 X A fee of \$0.00 to cover recordation of the Assignment(s).
 X Please charge my Deposit Account No. 19-2179 in the amount of \$710.00. A
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 X Any additional filing fees required under 37 CFR 1.16.
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 X Any patent application processing fees under 37 CFR 1.17
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Respectfully submitted,



Stanton C. Braden
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Date: 9/28/01

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** TOTAL PAGE.08 **

APPLICATION FOR LETTERS PATENT
OF THE UNITED STATES

Linda X. Chen
Citizen of China

Larry Varnerin
Citizen of United States

TITLE OF INVENTION:

DIRECT, NON-DESTRUCTIVE MEASUREMENT OF
RECESS DEPTH IN A WAFER

TO WHOM IT MAY CONCERN, THE FOLLOWING IS
A SPECIFICATION OF THE AFORESAID INVENTION